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Notice of Allowability	Application No.	Applicant(s)	<del></del>
	10/766,710	LEE, HEON	
	Examiner	Art Unit	
	Kin-Chan Chen	1765	
	Kill-Chall Chell	1703	
The MAILING DATE of this communication apper All claims being allowable, PROSECUTION ON THE MERITS IS therewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in the or other appropriate communing GHTS. This application is sufficient to the community of the commun	his application. If not included ication will be mailed in due co	l ourse. <b>THIS</b>
1. This communication is responsive to			
2. 🔀 The allowed claim(s) is/are <u>1-32</u> .			
3. Acknowledgment is made of a claim for foreign priority un	nder 35 U.S.C. § 119(a)-(d) or	(f).	
a) ☐ All b) ☐ Some* c) ☐ None of the:		• •	
1. Certified copies of the priority documents have	been received.		
2.  Certified copies of the priority documents have	been received in Application	No	
3.  Copies of the certified copies of the priority doc	cuments have been received i	n this national stage application	on from the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		reply complying with the requ	iirements
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			TICE OF
5. CORRECTED DRAWINGS ( as "replacement sheets") mus	st be submitted.		
(a) ☐ including changes required by the Notice of Draftspers		PTO-948) attached	
1) 🔲 hereto or 2) 🗍 to Paper No./Mail Date			
(b) including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in	n the Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			eack) of
<ol> <li>DEPOSIT OF and/or INFORMATION about the depo- attached Examiner's comment regarding REQUIREMENT</li> </ol>			ote the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. Notice of Info	rmal Patent Application (PTO	-152)
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Sun	• • • • • • • • • • • • • • • • • • • •	•
_ ,	Paper No./M	ail Date	
<ol> <li>Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 012704</li> </ol>	oo), (. ∐ Examiner's A	mendment/Comment	
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛛 Examiner's S	tatement of Reasons for Allov	vance
	9. 🗌 Other		

## **DETAILED ACTION**

## **REASONS FOR ALLOWANCE**

The following is an examiner's statement of reasons for allowance:

The most relevant references in the list of prior art cited are Lee (US 6,755,984) and Voisin (US 2003/0205657) who teach methods for forming imprint stamp or template. However, they do not teach or suggest a method comprising: after depositing a first layer on the etched and patterned substrate, patterning and etching the first layer to form an application specific imprint pattern in the first layer; repeating the depositing, the patterning, and etching until the specific imprint pattern is completed defined; segmenting the substrate to form an imprint blank; etching the exposed cross-sectional surface of the imprint blank to form the imprint stamp. A person of ordinary skill in the art would not have been motivated to perform aforementioned steps because the prior art merely generates the line and space patterns that are substantially parallel to each other.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kin-Chan Chen whose telephone number is (571) 272-1461. If attempts to reach the examiner by telephone are unsuccessful, the examiner's

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supervisor, Nadine Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

March 16, 2006

Kin-Chan Chen Primary Examiner Art Unit 1765